

10/078354



03/11/02

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PATENT NUMBER and  
ISSUE DATE

## U.S. UTILITY Patent Application

APPL NUM 10078354	FILING DATE 02/21/2002	CLASS 438	SUBCLASS 795	GAU 2812	EXAMINER H Lee
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\*\*APPLICANTS: Zhang Hongyong.

\*\*CONTINUING DATA VERIFIED: *Lee*  
THIS APPLICATION IS A DIV OF 08/089,650 07/12/1993  
WHICH IS A CON OF 07/707,092 05/29/1991 ABN  
*Yes*\*\* FOREIGN APPLICATIONS VERIFIED: *Lee*JAPAN 02-145069 06/01/1990  
*Yes*PG-PUB DO NOT PUBLISH ☐RESCIND ☐

Foreign priority claimed

☐ yes ☐ no

35 USC 119 conditions met

☐ yes ☐ no

Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO

740756-2440

TITLE : Method for fabricating thin-film transistor

U.S. DEPT. OF COMM. PAT. &amp; TM. PTO. 436 (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drwg.	Figs. Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner	
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